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新聞稿 PRESS RELEASE

**Chinese University received million-dollar donation
from Sun Microsystems**

The Chinese University of Hong Kong has received a donation of new computer equipment from Sun Microsystems with a market value exceeding HK\$1,000,000.

The equipment, manufactured by the Sun Microsystems plant in Mountain View, California, consists of one SPARCserver 330, three SPARCstation 1+ workstations and two SPARCstation SLC workstations. They have already been installed last November at the Open Systems Laboratory in the Computer Science Department of the University, and are now linked together as a cluster of the Chinese University Engineering Computer Network, capable of being accessed remotely from workstations and personal computers anywhere in Hong Kong using the UNIX operating system.

This donation reflects Sun Microsystems' interest in promoting academic excellence, and will be used to study UNIX-based distributed computing environments and related problems.

A ceremony was held on May 13 in the Computer Science Department of The Chinese University to mark the generous donation from Sun Microsystems and the opening of the Open Systems Laboratory. Professor Charles K Kao, Vice-Chancellor of CUHK who officiated at the ceremony said: "The donation of Sun workstations last November was extremely timely as it greatly increased our workstation computing power. The Sun Workstations have proven to be very popular. The laboratory became crowded almost immediately."

The Vice-President for Asia of Sun Microsystems, Mr Neil Mathison, was also present at the ceremony. "We are pleased to be contributing to the development of UNIX expertise in Hong Kong", Mr Mathison said, "Sun has always placed a special priority on academia and will continue to support these worthy institutions in Asia".

Attached picture: Prof Charles K Kao, Vice-Chancellor of CUHK unveiling the plaque of the Open Systems Laboratory

May 13, 1991